

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Confirmation No.: 7738
Mitsuhiro ICHIO et al.)	
Application No. 10/804,053)	Examiner: Long Pham
Filed: March 19, 2004)	Group Art Unit: 2814
For: FILM FORMATION METHOD AND)	Date: March 3, 2008
MANUFACTURING METHOD OF)	
SEMICONDUCTOR DEVICE)	

EX PARTE QUAYLE RESPONSE

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the *Ex parte* Quayle Office Action mailed January 3, 2008, please amend the above-identified application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 9 of this paper.